

Form PTO-1449

Docket Number 511582001621

Application Number 10/010,667

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

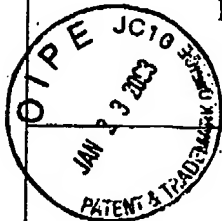
Applicant AFAR, et al.

Filing Date 6 December 2001

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Mailing Date January 28, 2003

(Use several sheets if necessary)



U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
GN	1.	21-Feb-02	US2002022248-A1	Xu et al.	-	-	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
GN	2.	22-Jun-99	JP11164691-A	Japan			
GN	3.	27-Jan-00	WO200004149-A2	WIPO			X
	4.	21-Dec-00	WO200077021-A1	WIPO			
	5.	12-Apr-01	WO200125272-A2	WIPO			
	6.	17-May-01	WO200134802-A2	WIPO			
	7.	7-Jun-01	WO200140276-A2	WIPO			
	8.	19-Jul-01	WO200151633-A2	WIPO			
	9.	9-Aug-01	WO200157190-A2	WIPO			
	10.	9-Aug-01	WO200157276-A2	WIPO			
	11.	9-Aug-01	WO200157277-A2	WIPO			
	12.	23-Aug-01	WO200160860-A2	WIPO			
	13.	4-Oct-01	WO200173032-A2	WIPO			

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